

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Gealy et al.

**Serial No.:** Not yet assigned

**Filed:** July 22, 2003

**For:** METHOD FOR STABILIZING HIGH  
PRESSURE OXIDATION OF A  
SEMICONDUCTOR DEVICE

**Examiner:** Unknown

**Group Art Unit:** Unknown

**Attorney Docket No.:** 3403.4US  
(97-0758.04/US)

**NOTICE OF EXPRESS MAILING**

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**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This application is a continuation of application Serial No. 10/212,892, filed August 5, 2002, pending, which is a continuation of application Serial No. 09/798,445, filed March 2, 2001, pending, which is a divisional of application Serial No. 09/386,941, filed August 31, 1999, now U.S. Patent 6,291,364, issued September 18, 2001.

Pursuant to M.P.E.P. 2001.06(b), the Examiner is respectfully requested to consider the information of record in the prior application, and to confirm in the first Office Action on the merits that

**Attorney Docket No. 3403.4US (97-0758.04/US)**

such art has in fact been reviewed. A PTO-1449 form listing all of the information of record in the prior application is enclosed herewith.

This Information Disclosure Statement is filed within three (3) months of the filing date of the above-identified application, and no certification pursuant to 37 C.F.R. § 1.97(c) or a fee pursuant to 37 C.F.R. 1.17(p) is required.

Respectfully submitted,



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Date: July 22, 2003

JRD/sls:djp

Enclosure: Form PTO-1449

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Form PTO-1449  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  <i>(Use several sheets if necessary)</i>			Docket Number (Optional) <b>3403.4US (97-0758.04/US)</b>		Application Number <b>N t yet assigned</b>	
			Applicant <b>Gealy et al.</b>			
			Filing Date <b>July 22, 2003</b>		Group Art Unit <b>Unknown</b>	

  

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,382,533	01/1995	Ahmad et al.			
	5,416,045	05/1995	Kauffman et al.			
	5,479,955	01/1996	Roodvoets et al.			
	5,569,936	10/1996	Zhang et al.			
	5,595,923	01//1997	Zhang et al.			
	5,595,944	01/1997	Zhang et al.			
	5,606,179	02/1997	Yamazaki et al.			
	5,624,865	04/1997	Schuegraf et al.			
	5,646,075	07/1997	Thakur et al.			
	5,646,424	07/1997	Zhang et al.			
	5,840,600	11/1998	Yamazaki et al.			
	6,291,364	09/2001	Gealy et al.			
	6,423,649	07/2002	Gealy et al.			
	6,596,651	07/2003	Gealev et al.			

  

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

  

OTHER DOCUMENTS			(Including Author, Title, Date, Pertinent Pages, Etc.)
		Nitrated Oxides, Silicon Processing for the VLSI Era - Volume III, Pages 648-661.	

  

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance. Include copy of this form with next communication to the applicant.